

Docket No.: 63979-028



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Takashi NISHIKAWA, et al.	:	Confirmation Number: 2411
	:	
Serial No.: 10/616,917	:	Group Art Unit: 2811
	:	
Filed: July 11, 2003	:	Examiner: Unknown
	:	
For: A SEMICONDUCTOR DEVICE AND A FABRICATION METHOD THEREOF	:	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Upon review of the PTO-Form 1449 filed on October 9, 2003, the client has noted an inverted error in one of the references. Its is respectfully requested that the revised Form 1449 herein be considered. The references listed have already been submitted to the PTO.

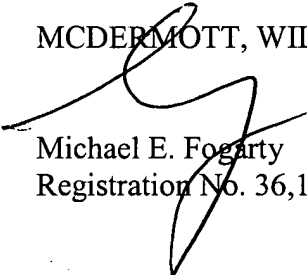
This Supplemental Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

10/616,917

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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Date: December 9, 2003

